Half-Mode Substrate Integrated Waveguide Amplifier Using Lumped-Element Transition

Dong-Sik Eom · Hai-Young Lee*

Abstract

This paper proposes a half-mode substrate integrated waveguide (HMSIW) amplifier using lumped-element transition. The input and output impedances of this amplifier are matched by the lumped-element transition structure. This structure provides compact impedance and mode matching circuits between the HMSIW and a stand-alone amplifier. Surface mount technology inductors and capacitors are implemented to realize the lumped-element transition. A prototype of the proposed HMSIW amplifier shows 15 dB gain with 3 dB bandwidth of 4 to 7.05 GHz in a simulation and measurement.

Key Words: Amplifier, Half-Mode Substrate Integrated Waveguide (HMSIW), Lumped Element, Substrate Integrated Waveguide (SIW), Transition.

I. INTRODUCTION

A substrate integrated waveguide (SIW) is a well-known type of planar formed waveguide on a printed circuit board (PCB). An SIW is formed with two parallel metallic via holes or grooves in the PCB. Compared with traditional, bulky waveguide, an SIW provides easy-to-fabricate structures, small-sized circuits, and good integration with planar circuits. Studies have already developed various passive and active SIW circuits and devices [1-10]. Of these active SIW amplifiers [1-4] are complicated to design because the signal and ground of the SIW are electrically shorted by metalized via holes or grooves, and they need input and output impedance matching as well as mode conversion circuits between the amplifier and the SIW. A mode conversion circuit, also called the transition structure between the SIW and the planar transmission lines-microstrip (MS), coplanar waveguide (CPW) or conductor-backed coplanar waveguide (CBCPW)-is needed because the SIW and planar transmission lines have different mode characteristic.

An X-band SIW amplifier using a DC-decoupled transition structure between the SIW and the MS was firstly proposed [1]. However, the DC-decoupled transition structure has to be designed very carefully, because the mode and impedance matching properties are very sensitive to the coupling factor of the DC-decoupled transition. SIW power amplifiers using CB-CPW-to-SIW and MS-to-SIW transitions were proposed to realize an input/output matching network in the SIW [2, 3]. However, it is hard to tune the matching network after PCB fabrication, and the transition length between the SIW and the CBCPW or MS remains long. Note that the long transition structure may cause unwanted coupling and radiation around the circuits [7]. A corrugated SIW distributed amplifier was also reported; however, its performance was not optimized [4].

This study proposes a half-mode SIW (HMSIW) amplifier using HMSIW-to-MS lumped-element transition. The proposed structure was developed using an HMSIW platform that

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reduces the SIW structure size by half, and it supports the $TE_{0.5,0}$ half-mode [8]. The lumped-element transition structure was realized using a surface mount technology (SMT) inductor and capacitor to reduce the length of the conventional transition structure [9, 10]. The proposed structure is easy to design and enables tuning of the amplifier input/output matching network by using lumped-element transition after PCB fabrication.

II. HMSIW TRANSITION TO MICROSTRIP AND HMSIW Amplifier Design

Fig. 1(a) and (b) show the conventional and incomplete transition structures, MS-HMSIW-MS [5] and MS-HMSIW, respectively, on the Taconic TLX substrate (dielectric constant = 2.55, height = 0.508 mm). These transition structures were verified by simulation using ANSYS HFSS ver. 14. Note that ports 1 and 2 in Fig. 1(a) and (b) were excited as a 50- Ω lumped port, and not a wave port in the HFSS simulation.

Fig. 2 shows simulation results of the MS-HMSIW-MS and MS-HMSIW structures. In Fig. 2(a), the simulated return losses of the MS-HMSIW-MS are under -15 dB from 4.13 to 6.8 GHz, and in Fig. 2(b), the MS-HMSIW-MS structure shows good matching at 50 Ω from the Smith chart. Note that the simulated HMSIW length is $\lambda_c/4 \approx 30$ mm. Fig. 2(c) shows the simulated return losses of the incomplete MS-HMSIW transition. However, the incomplete transition structure shows return losses of around -8 dB at ports 1 and 2 because the port-2 impedance is not located on 50 ohm. The port-2 impedance is located at 24.86 + *j*12.63 Ω at 6 GHz, as seen in the Smith chart in Fig. 2(d). To match the port-2 impedance to 50 Ω , a lumped-element matching circuit is used.

Murata SMT 0.2 nH series inductor with 0603 mm² size and a 0.4-pF shunt capacitor were used between the HMSIW and



Fig. 1. (a) Conventional MS-HMSIW-MS transition structure. (b) Incomplete MS-HMSIW transition structure.



Fig. 2. (a) Simulated return loss of conventional MS-HMSIW-MS transition. (b) Smith chart of simulated reflection coefficient of conventional transition. (c) Simulated return loss of incomplete MS-HMSIW transition. (d) Smith chart of simulated reflection coefficient of incomplete transition.

the MS, as shown in Fig. 3(a). Note that the shunt capacitor is bridged with the MS-edge and the extended top-grounded metal pad. The 0.2 nH series inductor moved the 24.86 + *j*12.63 Ω impedance to 25.1 + *j*24.77 Ω at 6 GHz, and the 0.4 pF shunt capacitor changed the 25.1 + *j*24.77 Ω impedance to 50 Ω , as shown in Fig. 3(b). As a result, the return losses improved after evaluating the proposed lumped-element transition,



Fig. 3. (a) Lumped-element matching circuit between HMSIW and MS. (b) Simulated port-2 reflection coefficient after lumpedelement matching. (c) Simulated return losses after lumpedelement matching.

as shown in Fig. 3(c). Note that the 50 Ω lumped-port was induced to ports 1 and 2 in the HFSS simulation, as shown in Fig. 3(a).

The back-to-back transitions of conventional [5] and lumped-element transition [9] structures were designed and compared to verify the performance, as shown in Fig. 4(a) and (b). The lumped-element transition has a short transition length compared with the conventional transition, as shown in Fig. 4(a). The 0.2 nH series SMT inductor and 0.4 pH shunt capacitor were attached on the matching section. SMA connectors were soldered to the edge of the MS line for the measurement. The measurements were conducted using the Agilent N5230A vector network analyzer. Fig. 4(b) shows the measured Sparameters of the conventional and lumped-element transition structures. The measured insertion loss of the lumped-element structure remains within 0.7 dB from 4.15 to 6.88 GHz. The measured return loss is below -15 dB from 4.2 to 6.7 GHz. The return loss bandwidth of the lumped-element transition structure is narrower than that of the conventional structure because lumped-element matching provides a narrower bandwidth than distributed matching of the tapered line [11]. However, the lumped-element transition structure provides a physically short transition length and shows insertion loss similar to that of the



Fig. 4. (a) Back-to-back transition structure of conventional and lumped-element designs. (b) Measured *S*-parameters of conventional and the proposed designs.



Fig. 5. Building blocks of proposed HMSIW amplifier.

conventional structure in the pass-band.

Fig. 5 shows the proposed HMSIW amplifier design and its building blocks. The amplifier is bridged with the HMSIW through the SMT matching section, which plays a role in the HMSIW-to-MS transition and input/output matching networks of the amplifier. Mini-circuit GALI-33+ amplifier was implemented to demonstrate the proposed HMSIW amplifier, and the input and output of the amplifier have 50 pF DC-block capacitors. The input and output impedances of the GALI-33+ amplifier are 50 Ω . Note that if the input/output of the amplifier are not 50 Ω , the input/output impedances of the amplifier should be matched with the HMSIW by changing the values of the lumped-elements.

III. EXPERIMENTAL RESULTS

Fig. 6 shows the proposed HMSIW amplifier. This amplifier is biased at 4.3 V with dc current of 45 mA. The proposed am-



Fig. 6. Proposed HMSIW amplifier.



Fig. 7. Measured S-parameters of proposed HMSIW amplifier and stand-alone amplifier.

plifier was simulated and measured. Fig. 7 shows the simulated and measured small-signal gain and return loss of the proposedstructure compared with that of the measured stand-alone amplifier. The proposed amplifier has 15 dB gain with 3 dB bandwidth from 4 to 7.05 GHz. The measured return loss is as low as 10 dB from 4.04 to 6.99 GHz. The measured results show good agreement with the simulation results.

IV. CONCLUSION

This study proposes an HMSIW amplifier with a lumpedelement transition circuit. The lumped-element transition structure has short transition length, and it may reduce the possible radiation to nearby devices compared with the conventional transition structure. The proposed HMSIW amplifier was designed, simulated, and measured. The results indicate that it is promising for small-sized SIW circuit integration.

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